

**INFORMATION DISCLOSURE CITATION***(Use several sheets if necessary)*

Docket Number (Optional)

**NEC A433**

Application Number

Applicant(s)

**TOUNAI**

Filing Date

**March 31, 2004**

Group Art Unit

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
/E.P./		2000-214577	04.08.2000	JAPAN (w/Abstract)	G03F	1/08		✓
/E.P./		11-338904	10.12.1999	JAPAN (w/Abstract)	G06F	17/50		✓
/E.P./		11-096200	09.04.1999	JAPAN (w/Abstract)	G06F	17/50		✓
/E.P./		2000-294650	20.10.2000	JAPAN (w/Abstract)	H01L	21/82		✓

**OTHER DOCUMENTS** *(Including Author, Title, Date, Pertinent Pages, Etc.)*


EXAMINER

/Edward Park/

DATE CONSIDERED

06/21/2007

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